

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Jong-Hwan CHA, *et al.*

Application No.: To be assigned

Filed: Herewith

For: **APPARATUS FOR MANUFACTURING
A THIN FILM TRANSISTOR ARRAY
PANEL FOR A LIQUID CRYSTAL
DISPLAY (AS AMENDED)**

Art Unit: To be assigned

Examiner: To be assigned

Atty. Docket: 06192.0094.DVUS01

Preliminary Amendment

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Please amend the above-identified patent application as follows.

Amendments

In the Title:

Please amend the title to read: -- Apparatus for Manufacturing a Thin Film Transistor
Array Panel For a Liquid Crystal Display --.

In the Claims:

Please cancel claims 1-9 and add new claim 10 as follows:

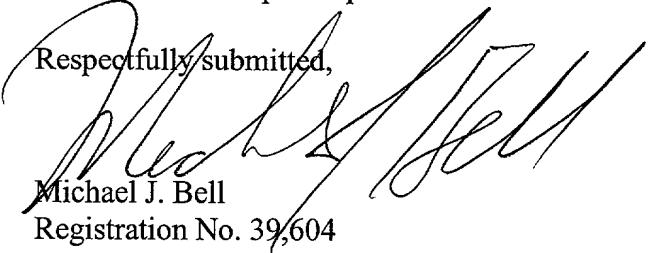
10. (New) An apparatus for depositing a layer on a substrate, comprising:
 - a loadlock chamber that receives a substrate;
 - a preheat chamber that heats the substrate before deposition;

a process chamber that deposits a metal layer on the substrate,
wherein the substrate is transferred among the chambers in a vacuum while not
exposed to ambient atmosphere.

Conclusion

It is respectfully requested that this amendment be entered prior to the examination of the above-referenced patent application. It is believed that no new matter is added by this amendment. If the Examiner desires any additional information, the Examiner is invited to contact applicants' attorney at the telephone number listed below to expedite prosecution.

Respectfully submitted,


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Date: 2/14/01

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